ERRATUM

Erratum to: Effect of deposition energy on the microstructure and phase purity of pulsed laser deposited iron fluoride thin films

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The original version of this article unfortunately contained a mistake.

The first and last names of the author T. Rojhirunsakool were interchanged. The correct name is Tanaporn Rojhirunsakool.

The original article was corrected.

The online version of the original article can be found under doi:[10.1007/s00339-015-9334-6](https://doi.org/10.1007/s00339-015-9334-6).

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